

**CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)**

Applicant(s): Jifa Hao, et al.

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Examiner

Ori Nadav

Group Art Unit

2811

Invention: **POWER SEMICONDUCTOR DEVICE WITH HIGH AVALAN CHE CAPABILITY AND PROCESS FOR FORMING SAME**

I hereby certify that this Amendment (total 4 pages)

(Identify type of correspondence)

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